

272



Attorney Docket 0553-0403

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )  
)  
Keitaro IMAI )  
)  
Serial No.: 10/809,762 )  
)  
Filed: March 25, 2004 )  
)  
For: Display Device And Manufacturing )  
Method Thereof )  
)  
Art Unit: 2871 )  
)  
Examiner: Minh Toan T. Ton )  
)  
Confirm no. 7349 )

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents , P.O. Box 1450, Alexandria, VA 22313-1450 on <u>February 23 2006</u> (Date of Deposit) <u>Sharon Wallace</u> Name of applicant, assignee, or Registered Rep. <u>Sharon Wallace</u> <u>2/23/06</u> Signature Date	
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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE  
AND REQUEST FOR INITIALED 1449 FORM**

Sir:

In the Notice of Allowance of November 30, 2005, in his reasons for allowance, the Examiner states that “the prior art of record does not anticipate nor render obvious to one ordinary skilled in the art a method manufacturing a display device comprising a combination of various steps as claimed, more specifically, forming a conductive film over the substrate so as to cover the first wiring; forming a *resist* pattern on the conductive film by ink jetting...” (emphasis added). Applicants note that in Amendment A filed on October 27, 2005 (and received by the Patent Office on November 1, 2005) which the Notice of Allowance is in response, the word “resist” is struck out of (i.e. deleted from) independent Claim 7 and should not be a part of the reasons for allowance of

this claim.

The undersigned also had a telephone conference with the Examiner requested that the Examiner provide an initialed copy of the 1449 form, with initials provided to indicate his review of the Japanese references, from the IDS of March 25, 2004 be made of record. As all the other references are initialed, it is believed that the Examiner missed initialing these two references. A copy of the 1449 form in question is enclosed for the Examiner's benefit.

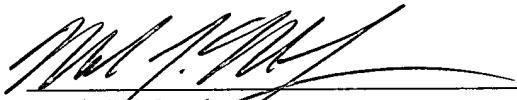
Further, the 1449 form lists US 2003/00546653. This is clearly a typographical error as such a document does not exist. Clearly, the document reviewed by the Examiner was US 2003/0054653. It is requested that the Examiner confirm this.

No fee is believed due for this submission. If any fee should be due for this submission, please charge our deposit account 50/1039.

Favorable consideration is earnestly solicited.

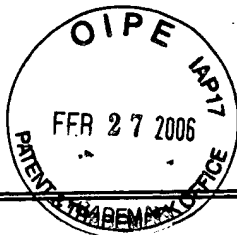
Respectfully submitted,

Date: February 23, 2006

  
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LIST OF PUBLICATIONS  
CITED BY APPLICANT

Atty Docket No.  
0553-0403

Serial No. 10/809762  
Not Assigned

Applicant  
Keitaro IMAI

Filing Date  
Herewith

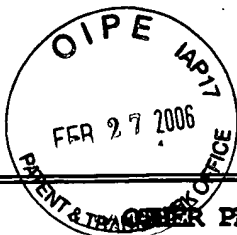
Group

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
M	5,117,299	05/26/92	Kondo et al	359	58	09/30/91
	5,132,676	07/21/92	Kimura et al	340	784	05/18/90
	5,240,801	08/31/93	Hayashi et al	430	57	12/16/92
	5,330,616	07/19/94	Yamazaki	156	643	10/23/92
	5,583,369	12/10/96	Yamazaki et al	257	635	03/12/96
	5,592,318	01/07/97	Majima et al	349	122	06/07/94
	5,652,667	07/29/97	Kurogane	349	42	11/06/95
	5,706,067	01/06/98	Colgan et al	349	114	02/21/97
	5,739,890	04/14/98	Uda et al	349	156	02/06/96
	5,754,263	05/19/98	Akiyama et al	349	110	11/01/96
	5,757,054	05/26/98	Miyawaki et al	257	390	09/16/96
	5,767,827	06/16/98	Kobayashi et al	345	87	12/22/95
	5,910,271	06/08/99	Ohe et al	252	299.01	08/16/96
	5,933,204	08/03/99	Fukumoto	349	43	06/27/96
	5,946,561	08/31/99	Yamazaki et al	438	166	11/29/96
	5,949,107	09/07/99	Zhang	257	347	11/05/96
	6,008,876	12/28/99	Moore	349	139	12/03/98
	6,037,197	03/14/00	Yamazaki et al	438	151	07/13/98
	6,049,132	04/11/00	Iwahashi et al	257	763	07/11/97
	6,294,815 B1	09/25/01	Yamazaki et al	257	350	04/20/00
	6,326,249 B1	12/04/01	Yamazaki et al	438	158	08/25/98
	6,468,844 B1	10/22/02	Yamazaki et al	438	156	01/05/00
	6,556,264 B1	04/29/03	Hirakata et al	349	110	04/22/98
	US 2003/ 0054653 A1	03/20/03	Yamazaki et al	438	694	03/19/02

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	APPLICANT	English Abstract	English Trans.	FILING DATE
	JP 10-303428	11/13/98	Semiconductor Energy Lab Co. Ltd	X		04/25/97
	JP 2002- 359246	12/13/02	Semiconductor Energy Lab Co. Ltd	X		03/27/02



**OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS**

(Include name of author (in CAPITAL LETTERS), title of article or item (book, magazine, journal, serial, symposium, catalog, etc.) date, pages(s), volume-issue number(s), publisher, city and/or country where published).

EXAMINER:

7.2

DATE CONSIDERED:

4/26/05

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.